

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Arthur Sherman
App. No	: 10/683,727
Filed	: October 10, 2003
For	: SEQUENTIAL CHEMICAL VAPOR DEPOSITION
Examiner	: Kelly M Stouffer
Art Unit	: 1792
Conf No.	: 1627

AMENDMENT AND RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action electronically transmitted on November 26, 2008, please amend the above-identified application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.